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MDS  
4.27.04  
NIT-254

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

G. OIKAWA et al

Serial No. 09/784,141

Group Art Unit: 2653

Filed: February 16, 2001

Examiner: C. Magee

For: MAGNETIC THIN FILM HEAD, THE FABRICATION  
METHOD, AND MAGNETIC DISK

RESPONSE TO RESTRICTION REQUIREMENT

RECEIVED

Commissioner for Patents  
Alexandria, VA 22313

APR 23 2004

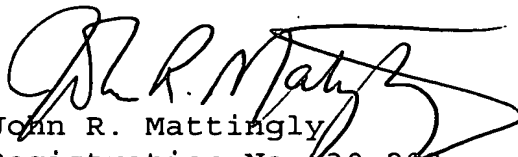
Technology Center 2600

Sir:

In response to the Restriction Requirement dated  
March 22, 2004, Applicants elect Group 1, drawn to the Ni  
composition of a formed layer part of a magnetic thin film  
head (claims 1, 2, 4, 8, and 10), without traverse.

The Commissioner is hereby authorized to charge any fee  
that may be required to Deposit Account No. 50-1417.

Respectfully submitted,

  
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